

APR 22 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya et al

Application No.: 09/648,095

Filed: August 25, 2000

Title: CHEMICAL MECHANICAL POLISHING  
TEST STRUCTURES AND METHODS FOR  
INSPECTING THE SAME

Attorney Docket No.: KLA1P016F

Examiner: Not assigned

Group: 2858

CERTIFICATE OF MAILING  
I hereby certify that this correspondence is being deposited with the  
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Signed:

*Natalie Morgan*  
Natalie Morgan

PRELIMINARY AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Please enter the following amendments prior to examination of the above-identified application.

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IN THE SPECIFICATION:

At page 1, line 7, please insert the following:

(1) This application is related to concurrently filed U.S. patent applications having application numbers 09/648,093, 09/648,380 09/648,109, 09/648,094, 09/648,212, 09/648,381, 09/648,096, 09/648,379 and 09/648,092.